

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Won-keun Yu, <i>et al.</i>
Serial No. – Pending	Filing Date: February 17, 2004
Title of Application:	Apparatus and Method for Positioning Back-Up Pins for Supporting Substrate

Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

Information Disclosure Statement by Applicants

Dear Sir:

As a means of complying with the duty of disclosure set forth in 37 CFR §1.56, Applicants list the following references (copies of the listed patents enclosed).

U.S. Patent Documents				
Exam. Initials	Class/ Subclass.	Document No.	Date	Name
	29/740	5,218,753	06/1993	Suzuki et al.
Foreign Patent Documents				
Exam. Initials	Document No.	Date	Country	
	03-214694	1991	Japan (with English abstract)	
	06-169198	1994	Japan (with English abstract)	

The listed patents pertain in a general way to the subject matter of the application, but are not necessarily considered to be analogous prior art.

Respectfully submitted,

February 17, 2004

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Date Considered

Examiner